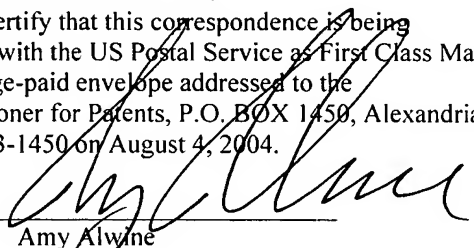


IFW



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| In re application of:<br>Uzoh et al.   | Group Art Unit: 2829<br>Examiner: Not yet assigned<br>Docket: NT-308-US   |
| Serial No.: 10/698,878   | CERTIFICATE OF MAILING<br>I hereby certify that this correspondence is being<br>deposited with the US Postal Service as First Class Mail<br>in a postage-paid envelope addressed to the<br>Commissioner for Patents, P.O. BOX 1450, Alexandria,<br>VA 22313-1450 on August 4, 2004. |
| Filed: October 31, 2003  | Signed: <br>Amy Alwine  |
| Title: Methods For Depositing High Yield And<br>Low Defect Density Conductive Films In<br>Damascene Structures |   |

### INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. BOX 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicants submit information herewith to comply with the obligations set forth in 37 CFR §1.56. This submission is not an admission that any of the documents are prior art or otherwise relevant to the subject application.

This IDS is submitted:

☐ with a filed patent application or within 3 months of the US application filing date;

☒ before the mailing of a first office action on the merits;

☐ after the first office action, but prior to a final rejection or notice of allowance, and is accompanied by the fee set forth in 37 CFR §1.17(p) or a certification set forth below; or

☐ after a final rejection or notice of allowance, and is accompanied by the fee set forth in 37 CFR §1.17(p) and a certification set forth below, where this submission is a petition requesting consideration of this IDS.


If identified above, Applicant certifies that:

☐ the information was first cited in a communication from a foreign patent office in a counterpart foreign application less than 3 months prior to this IDS; or

☐ to the knowledge of the person signing this certification after making reasonable inquiry, the information was not known to any individuals designated in 37 CFR §1.56 more than 3 months prior to this IDS.

If any matters can be resolved by telephone, Applicant requests that the Patent and Trademark Office call the Applicant at the telephone number listed below.

Respectfully submitted,

By:   
Daniel Hopen  
Reg. No. 35,547

NuTool, Inc.  
Legal Department  
1655 McCandless Drive  
Milpitas, CA 95035  
(408) 586-9500x268



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|---|---|
| In re application of:<br>Uzoh et al.<br><br>Serial No.: 10/698,878<br><br>Filed: October 31, 2003<br><br>Title: Methods For Depositing High Yield And<br>Low Defect Density Conductive Films In<br>Damascene Structures | Group Art Unit: 2829<br>Examiner: Not yet assigned<br>Docket: NT-308-US |
|---|---|

**INFORMATION DISCLOSURE STATEMENT**

**US PATENT DOCUMENTS**

| Examiner<br>Initials | Cite<br>No. | Document Number | Publication Date | Name of Patentee or<br>Applicant |               |
|----------------------|-------------|-----------------|------------------|----------------------------------|---------------|
|                      |             | 6,303,014       | Oct., 2001       | Taylor et al.                    | Copy Enclosed |
|                      |             | 6,210,555       | Apr., 2001       | Taylor et al.                    | Copy Enclosed |

**FOREIGN PATENT DOCUMENTS**

| Examiner<br>Initials | Cite<br>No. | Document<br>Number | Publication Date | Name of Patentee<br>or Applicant |  |  |
|----------------------|-------------|--------------------|------------------|----------------------------------|--|--|
|                      |             |                    |                  |                                  |  |  |

**OTHER DOCUMENTS**

| Examiner<br>Initials | Cite<br>No. |  |  | Trans-<br>lation |
|----------------------|-------------|--|--|------------------|
|                      |             |  |  |                  |

| Examiner<br>Signature |  | Date<br>Considered |  |
|-----------------------|--|--------------------|--|
|                       |  |                    |  |